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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450
Attention: Examiner Jose R. Diaz
Art Unit: 2815

December 19, 2003

Re: **SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD FOR...**
U.S. Application No.: 09/809,181
Attorney Docket No.: 503.39864X00

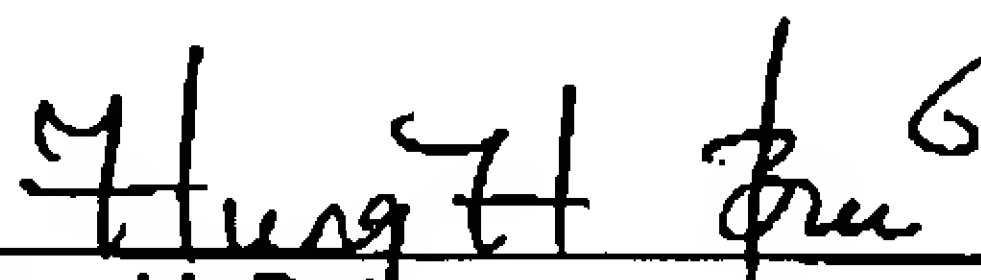
SUBMISSION OF DOCUMENTS

Sir:

Applicants hereby submit the attached "RESPONSE TO OUTSTANDING OFFICE ACTION" (20 pgs), "Petition for Extension of Time" and Credit Card Payment Form in the above-identified application.

CERTIFICATE OF TRANSMISSION:

I hereby certify that the attached "RESPONSE TO OUTSTANDING OFFICE ACTION" (20 pgs), "Petition for Extension of Time" and Credit Card Payment Form prepared in response to the Office Action dated on June 19, 2003, is being formally filed in the USPTO via Group 2815; Examiner Jose R. Diaz; Facsimile No. 703-872-9306 on **December 19, 2003**.


Hung H. Bui

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Toshiya SATOH et al.
Serial No.: 09/809,181
Filed: March 16, 2001
For: **SEMICONDUCTOR DEVICE AND MANUFACTURING
METHOD FOR HIGH RELIABILITY AND PRODUCTION YIELD
RATE WITH MINIMAL DAMAGE DUE TO APPLICATION OF
MECHANICAL STRESS AND THERMAL STRESS**
Group: 2815
Examiner: Jose R. Diaz

RESPONSE TO OUTSTANDING OFFICE ACTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

December 19, 2003

Sir:

In response to the non-final Office Action (Paper No. 23) dated on June 19, 2003, please consider and enter the arguments and remarks in the above-identified application as follows.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 9 of this paper.